

<b>Notice of References Cited</b>	Application/Control No. 10/603,701		Applicant(s)/Patent Under Reexamination KOEHLER ET AL.	
	Examiner Hai C Pham		Art Unit 2861	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2003/0058332	03-2003	FUJIWARA, KENSUKE	347/253
*	B	US-5,428,376	06-1995	Wade et al.	347/14
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
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**FOREIGN PATENT DOCUMENTS**

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	N					
	O					
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